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DEC-12-06 6:58PM;

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Attorney Docket No. INK-001

PATENT APPLICATION

DEC 12 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): In Kwon Jeong

Group Art Unit: 3723

Serial No. 10/765,613

Confirmation No. 1365

Filed: January 27, 2004

Examiner: Wilson, Lee D.

For: APPARATUS AND METHOD FOR POLISHING SEMICONDUCTOR
WAFERS USING ONE OR MORE PIVOTABLE LOAD-AND-UNLOAD
CUPS

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Sir/Madam:

In response to the Office Action mailed on September 13, 2006, please amend the above-identified patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in a listing of claims, which begins on page 9 of this paper.

Remarks begin on page 21 of this paper.

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CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. 1.8

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being facsimile transmitted to the Patent and Trademark Office facsimile number (311) 273-8300 on December 12, 2006.

Number of Pages: 28 (including TRANSMITTAL LETTER)

Signed: Thomas H. Ham
Typed Name: Thomas H. Ham